



**SW Test Workshop**  
Semiconductor Wafer Test Workshop

# Production Test RF Calibration for Multi-DUT Probe Cards: How to get the most accurate measurements



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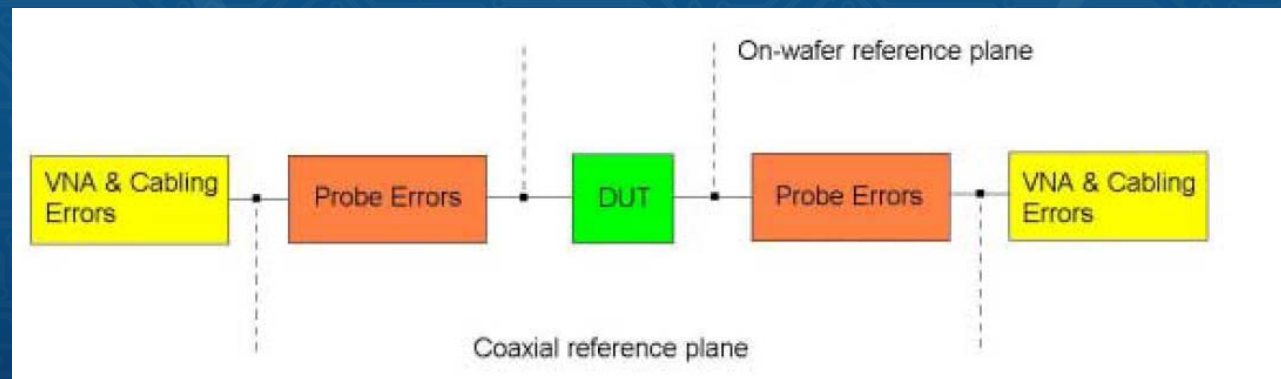
# Overview

- **What is Calibration?**
- **What are the differences between single site and multi-site calibration?**
- **Simulation investigation**
- **Summary**



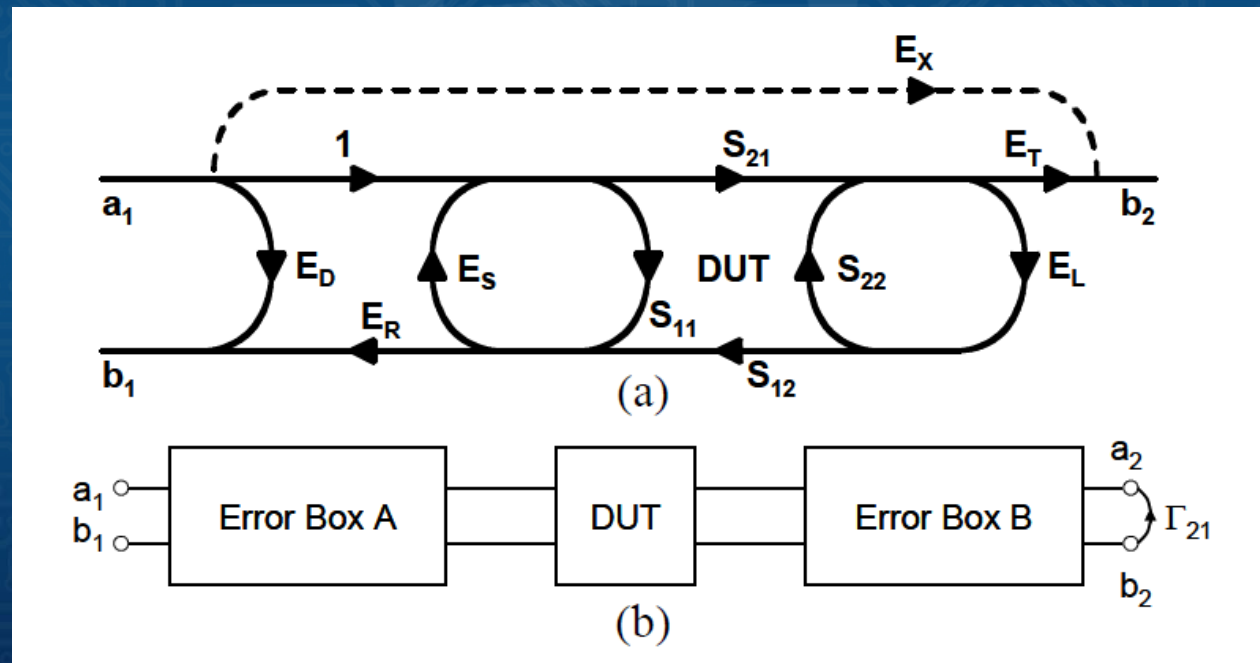
# Why do you need Calibration?

- You want a guarantee that you are measuring your DUT and NOT your test equipment
  - The Probes and cabling introduces errors
  - However, Calibration is able to remove those errors



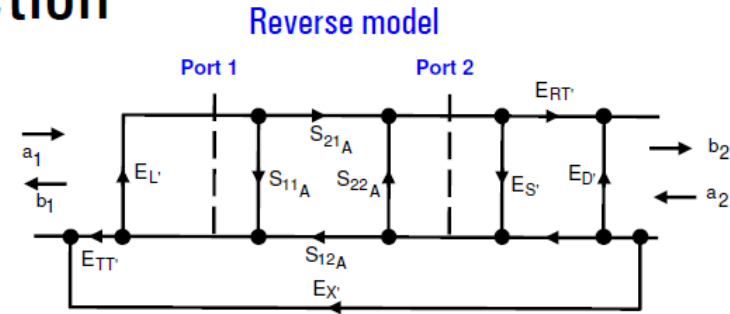
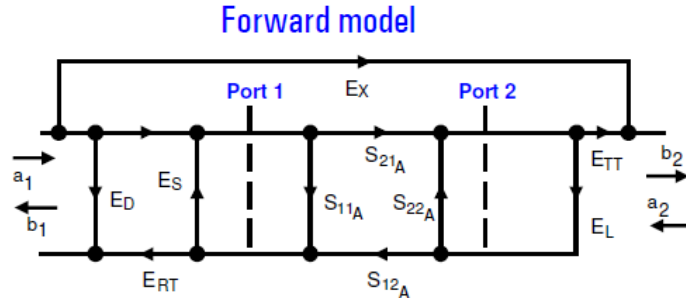
# How does Calibration Work

- It characterizes the RF performance parameters of your test hardware
- Then mathematically remove the parameters



# A Little Math...

## Two-Port Error Correction



$E_D$ = fwd directivity	$E_L$ = fwd load match
$E_S$ = fwd source match	$E_{TT}$ = fwd transmission tracking
$E_{RT}$ = fwd reflection tracking	$E_X$ = fwd isolation
$E_{D'}$ = rev directivity	$E_{L'}$ = rev load match
$E_{S'}$ = rev source match	$E_{TT'}$ = rev transmission tracking
$E_{RT'}$ = rev reflection tracking	$E_{X'}$ = rev isolation

- Each actual S-parameter is a function of all four measured S-parameters
- Analyzer must make forward *and* reverse sweep to update any one S-parameter
- Luckily, you don't need to know these equations to *use* network analyzers!!!

$$S_{11a} = \frac{\left(\frac{S_{11m} - E_D}{E_{RT}}\right)\left(1 + \frac{S_{22m} - E_{D'}}{E_{RT'}} E_{S'}\right) - E_L \left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)}{\left(1 + \frac{S_{11m} - E_{D'}}{E_{RT}} E_S\right)\left(1 + \frac{S_{22m} - E_{D'}}{E_{RT'}} E_{S'}\right) - E_{L'} E_L \left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)}$$

$$S_{21a} = \frac{\left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(1 + \frac{S_{22m} - E_{D'}}{E_{RT'}} (E_{S'} - E_L)\right)}{\left(1 + \frac{S_{11m} - E_D}{E_{RT}} E_S\right)\left(1 + \frac{S_{22m} - E_{D'}}{E_{RT'}} E_{S'}\right) - E_{L'} E_L \left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)}$$

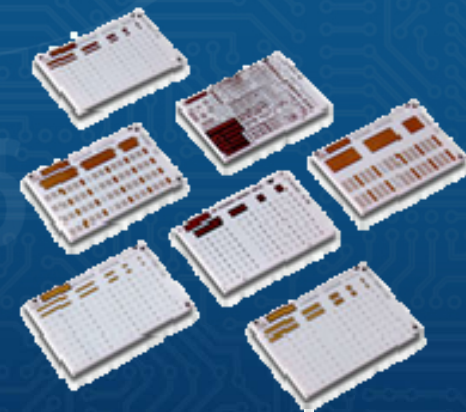
$$S_{12a} = \frac{\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)\left(1 + \frac{S_{11m} - E_D}{E_{RT}} (E_S - E_{L'})\right)}{\left(1 + \frac{S_{11m} - E_D}{E_{RT}} E_S\right)\left(1 + \frac{S_{22m} - E_{D'}}{E_{RT'}} E_{S'}\right) - E_{L'} E_L \left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)}$$

$$S_{22a} = \frac{\left(\frac{S_{22m} - E_{D'}}{E_{RT'}}\right)\left(1 + \frac{S_{11m} - E_D}{E_{RT}} E_S\right) - E_{L'} \left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)}{\left(1 + \frac{S_{11m} - E_D}{E_{RT}} E_S\right)\left(1 + \frac{S_{22m} - E_{D'}}{E_{RT'}} E_{S'}\right) - E_{L'} E_L \left(\frac{S_{21m} - E_X}{E_{TT}}\right)\left(\frac{S_{12m} - E_{X'}}{E_{TT'}}\right)}$$



# Calibration Substrates

- A calibration substrate is used in order to characterize the measurement path
  - Measure some combination of
    - Short
    - Open
    - Load
    - Thru



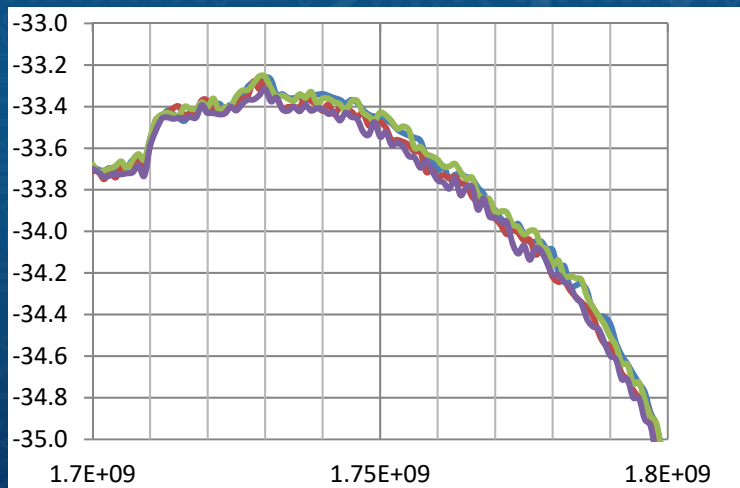
# But what about Multi-DUT?

- **In order to improve Cost Of Ownership, many companies are moving to multi-DUT test**
  - Increase number of wafers tested per probe card
  - Increase speed of test with lower number of index steps
- **But now DUT are being tested with different measurement sites, leading to the requirement for site-to-site correlation**

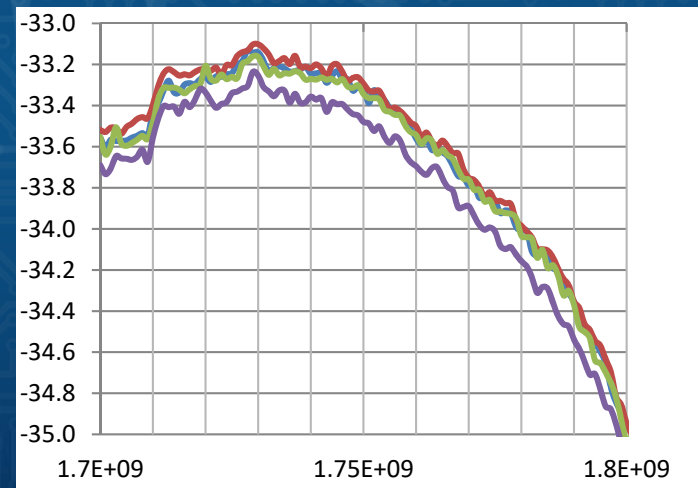


# Single Site Cal vs. Multi-site Cal

- Comparing a single site cal and a multi-site cal shows a bifurcation of the S-parameters
- Data indicates that the ISS using a multi-site cal has better correlation between sites on the same probe card measurement



Multi-site Cal

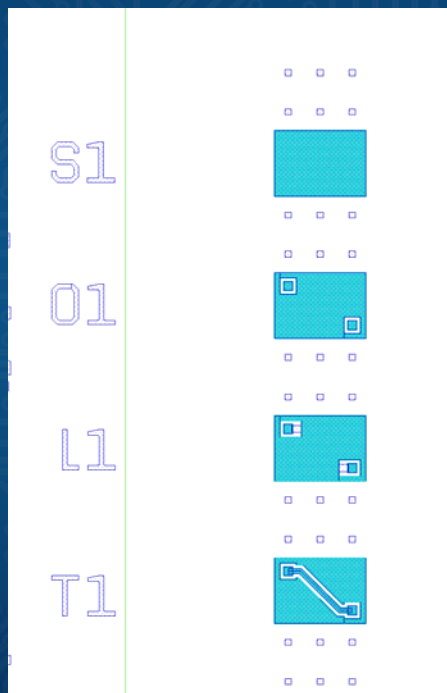


Single Site Cal

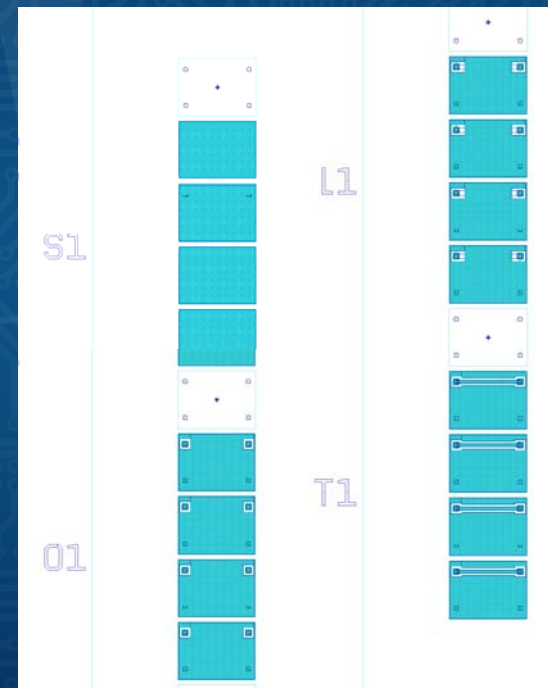


# What is the difference in a single site layout and multi-site?

- Figure showing the state of the adjacent DIE location



Single Site Standards



4-site Standards

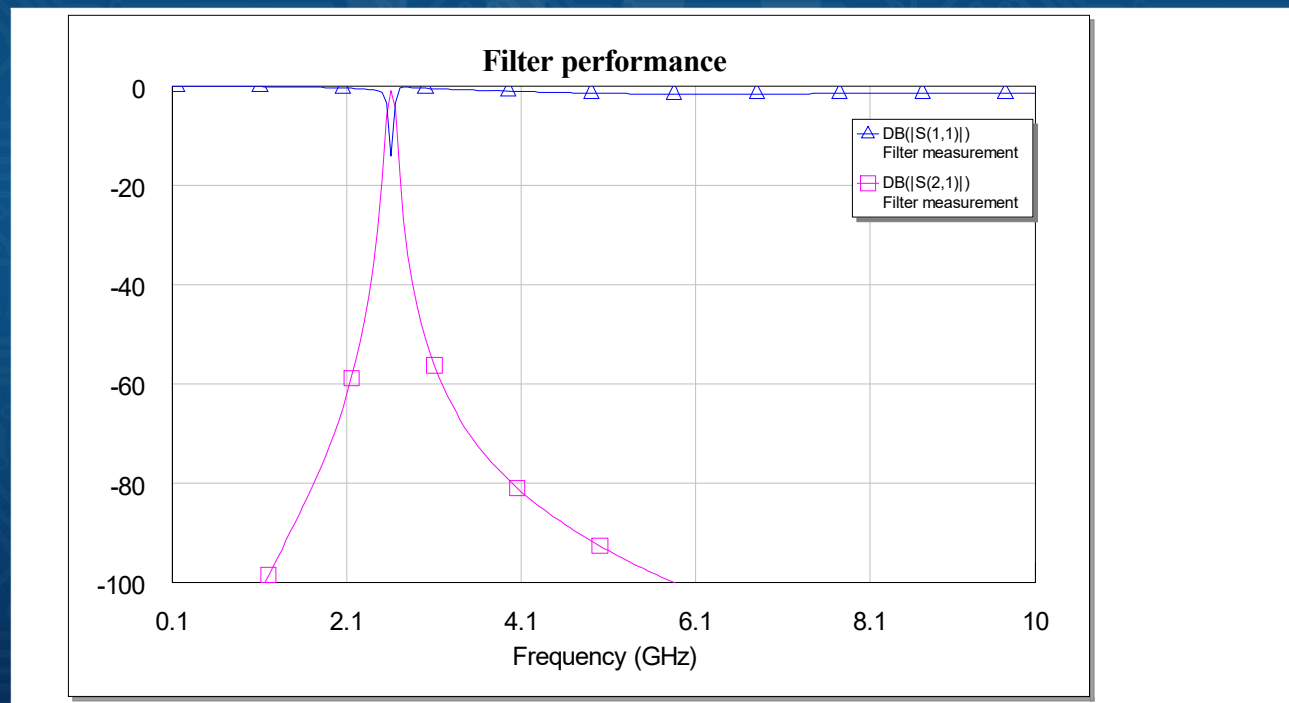
# Simulation Evaluation

- **In order to investigate further, we used simulation to control all other factors**
- **Simulate two die with same ground return**
  - Comparison between two different scenarios
    - Look at error terms when both ports are controlled (multi-site cal)
    - Look at the error terms when only one port is controlled, but the other can be a random state (single site cal) which includes short, open, load



# Filter measurement data

- The filter is a simple bandpass, with a center frequency of 2.6 GHz, with a 3 dB width of 100 MHz



# Cal Coefficients

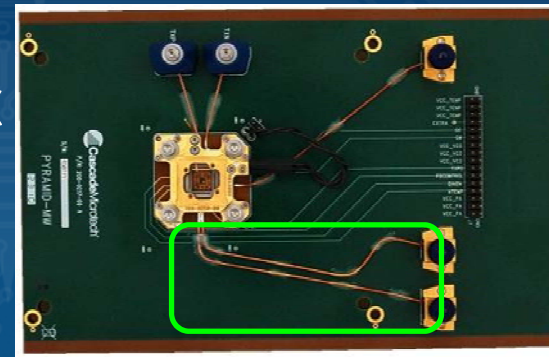
- In order to properly do SOLT calibration, we need to have cal coeff
- They were extracted using LRRM to calculate the values
  - L-load = 215 pF
  - L-short = 208 pF
  - C-open = 19 fF
  - Thru length = 4.8 ps



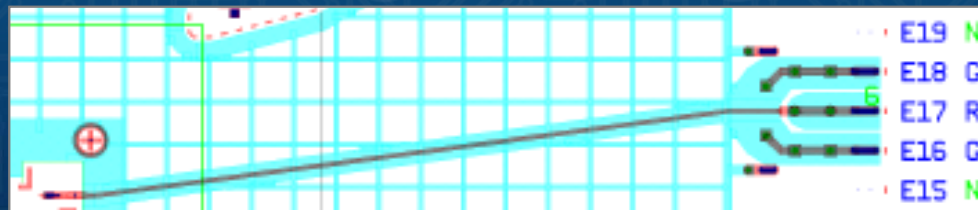
# Probe Card

- **The simulated probe card is modeled after a Pyramid Probe**

- 50 mm 0.031" semi-rigid coax

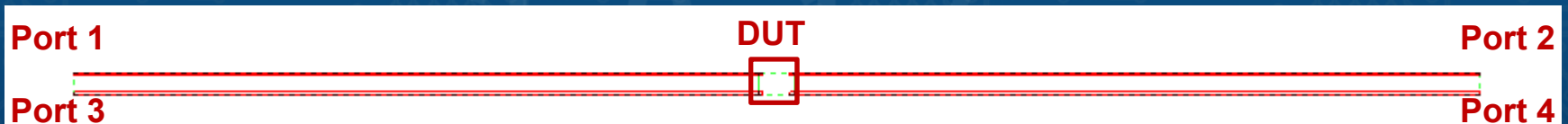


- 10 mm microstrip transmission line on the Pyramid Probe



# Membrane Layout

- **The design has a two filter layout**
  - Each filter has a single input/output pair
    - DUT 1 is port 1, 2
    - DUT 2 is port 3, 4
  - Shared ground return

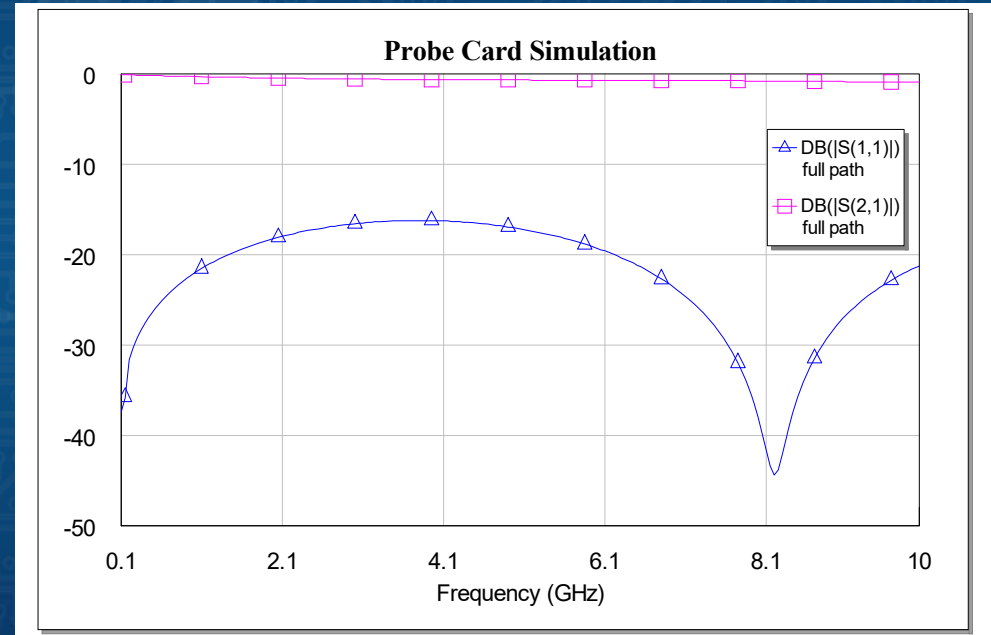




# Simulated performance of a single Channel

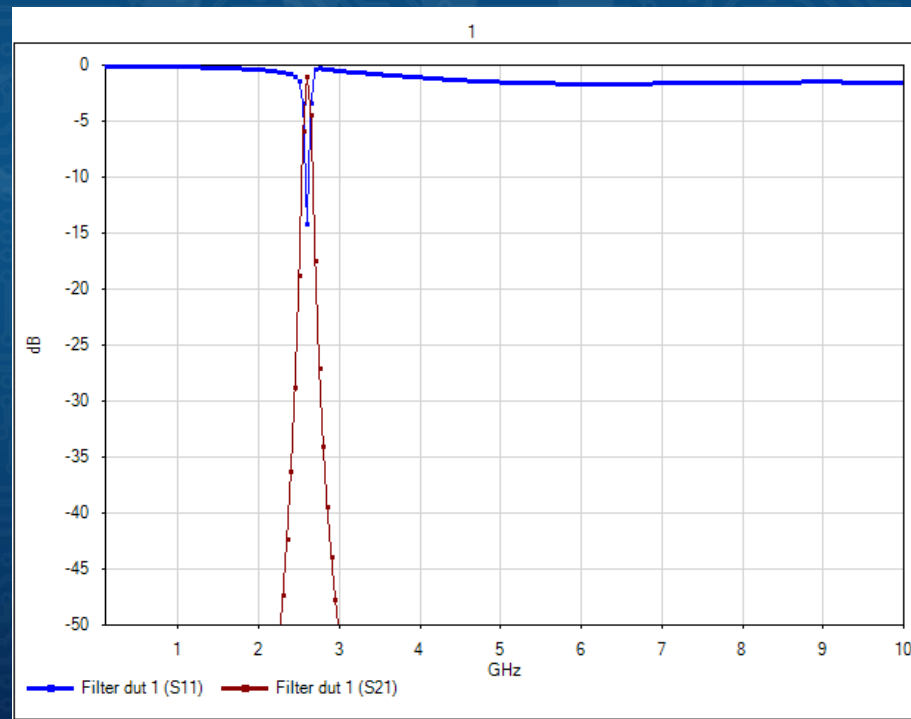
- The simulated probe card meets the standard specification of a Pyramid Probe:

- < 3 dB insertion loss
- > 10 dB return loss
- Cross talk is better than 55 dB at 2.5 GHz



# Measurements before Calibration

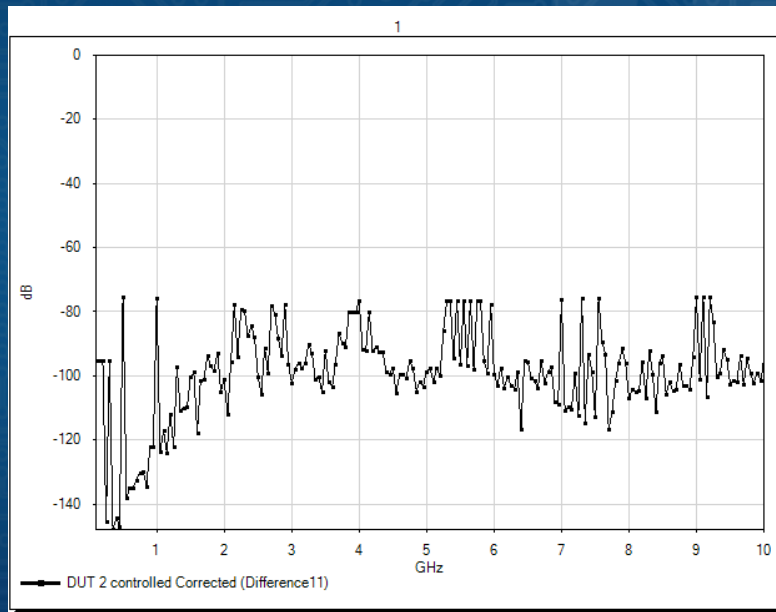
- The measurements prior to calibration are identical in each DUT
  - This is ideal scenario



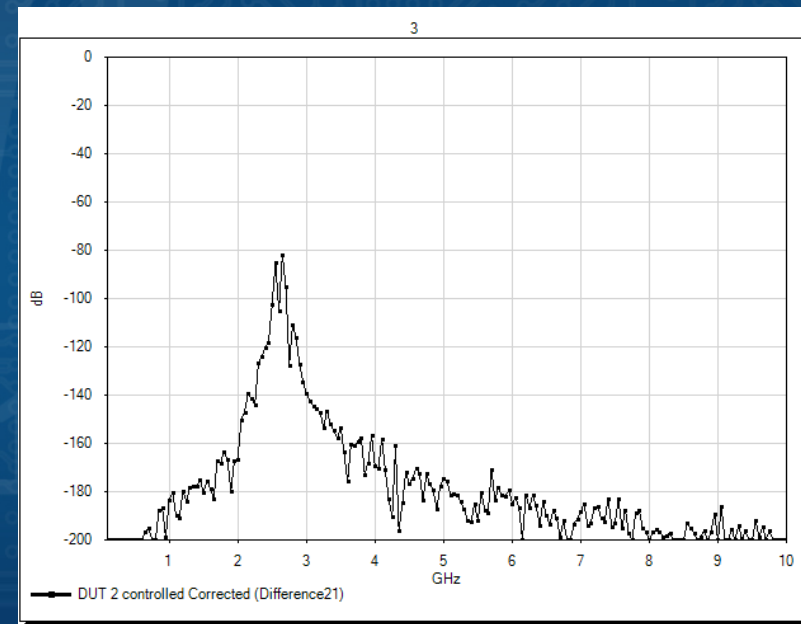


# After Calibration Controlled

- Looking at the different between DUT 1 and DUT 2, the variation is in the noise



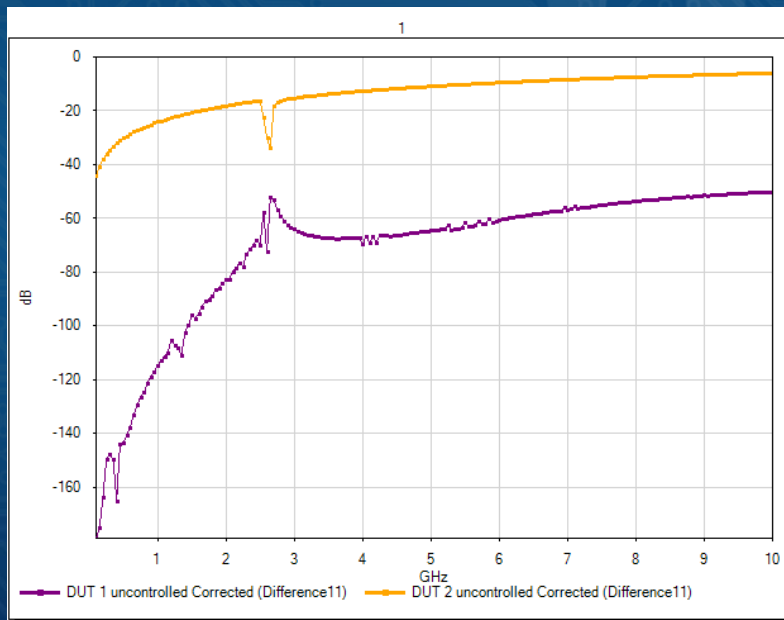
$\Delta$  Return Loss (S11)



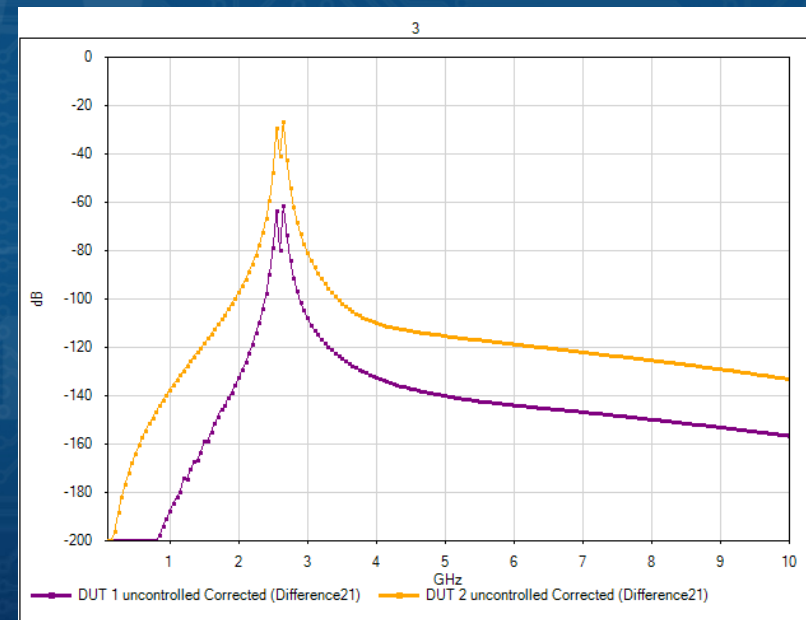
$\Delta$  Insertion Loss (S21)

# After Calibration Uncontrolled

- In the uncontrolled state for the unmeasured lines, it affects both sites, as well as making a bi-modal distribution
  - Compared to DUT 1 from the controlled state



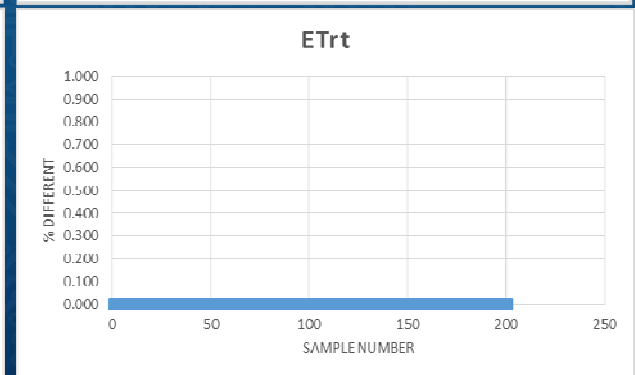
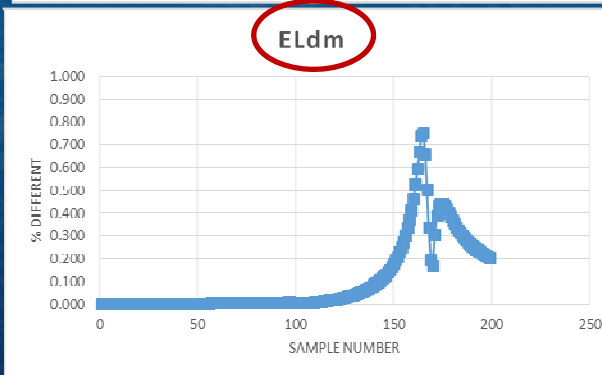
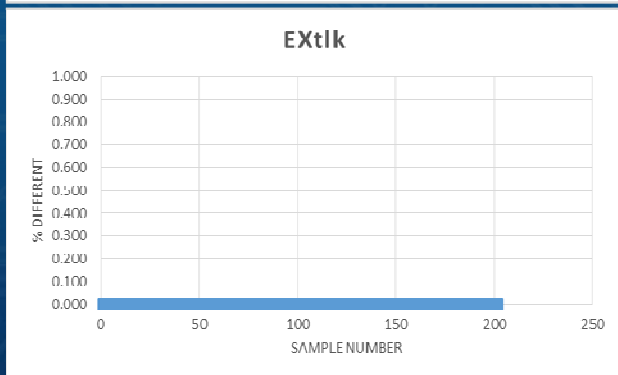
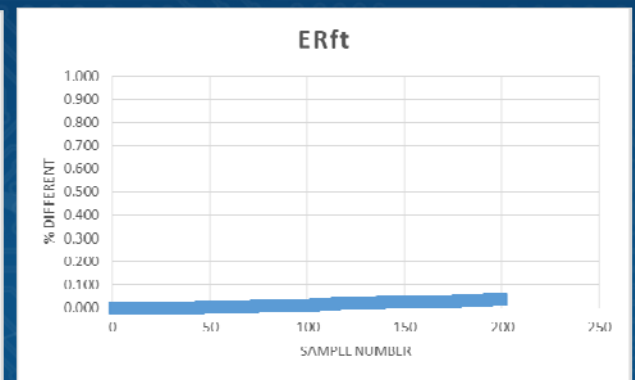
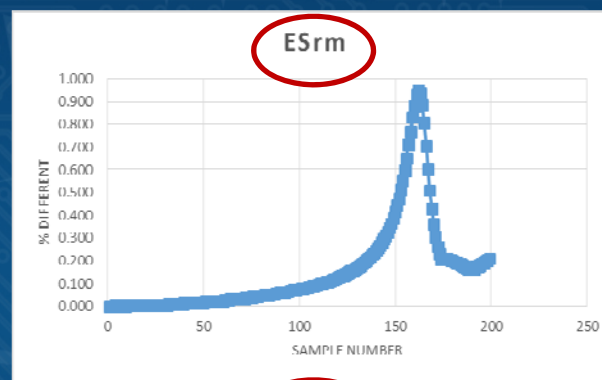
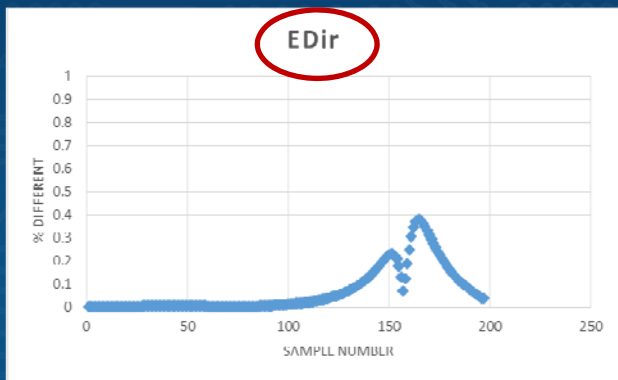
$\Delta$  Return Loss (S11)



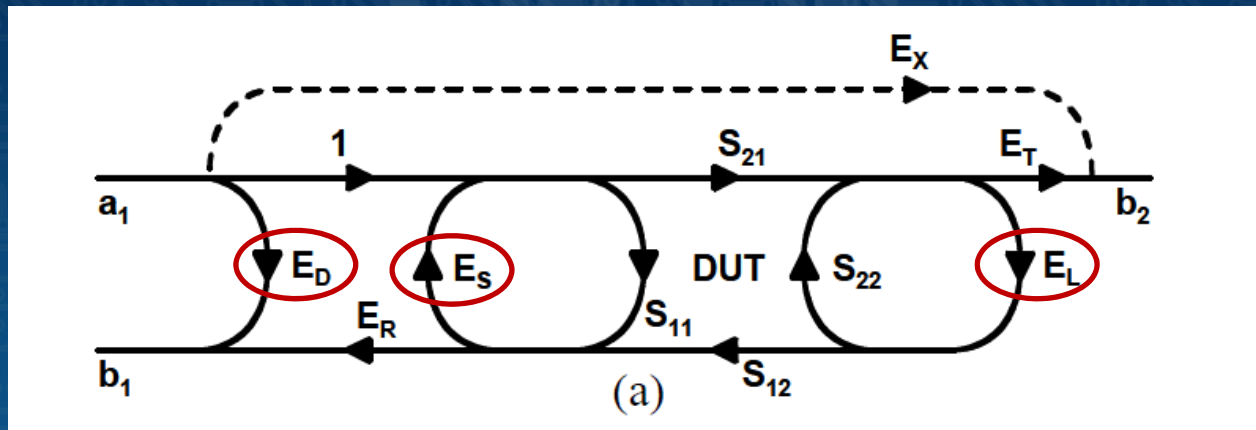
$\Delta$  Insertion Loss (S21)



# Which Error Terms are Most Affected?



# Which Error Terms are Most Affected?



- ES is most affected ( Source match)
- EL is next most (Load match)
- ED is third most (Directivity)
- The rest of the terms are affected less than 5%



# Summary

- **The most accurate measurement in a multi-site application is to make a calibration substrate that mirrors the multi-site layout**
  - Controls all of the RF traces for the highest correlation between sites